

<b>Notice of References Cited</b>	Application/Control No. 10/593,337		Applicant(s)/Patent Under Reexamination HEINRICH ET AL.	
	Examiner Shih-Chao Chen		Art Unit 2821	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,903,239	05-1999	Takahashi et al.	343/700MS
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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